



Application Serial No. 09/677,478  
Supplemental IDS

MI22-1544

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application Serial No. ....09/677,478  
Filing Date .....October 2, 2000  
Inventor .....Guy T. Blalock et al.  
Assignee .....Micron Technology, Inc.  
Group Art Unit .....1765  
Examiner .....Lan Vinh  
Attorney's Docket No. ....MI22-1544  
Title: Plasma Etching Methods

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**


Reference - - See attached Form PTO-1449

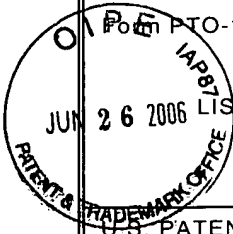
The attached Form PTO-1449 is submitted in compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the references listed on the attached Form PTO-1449. Pursuant to Federal Register Vol. 69, No. 182, pg. 56542 (September 21, 2004), no copies of any cited U.S. patents or U.S. published applications are included herewith. Copies of all other cited art references, if any, are attached. No admission is made regarding whether the submitted references are prior art.

Citation of this reference is respectfully requested.

Respectfully submitted,

Dated: 6-26-06

By:   
D. Brent Kenady  
Reg. No. 40,045

		Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1544		SERIAL NO. 09/677,478			
		<b>LIST OF ART CITED BY APPLICANT</b> (Use several sheets if necessary)						APPLICANT Guy T. Blalock et al.			
								FILING DATE October 2, 2000		GROUP 1765	
<b>U.S. PATENT DOCUMENTS</b>											
Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate				
	AA	6,800,561	10/04	Allen III	438	714					
	AB	6,878,300 B2	04/05	Allen III	216	058					
	AC										
	AD										
	AE										
	AF										
	AG										
	AH										
	AI										
	AJ										
	AK										
	AL										
<b>FOREIGN PATENT DOCUMENTS</b>											
		Document Number	Date	Country	Class	Subclass	Translation Yes No				
	AM										
	AN										
	AO										
	AP										
	AQ										
<b>OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)</b>											
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